Applicant(s)/Patent Under Reexamination 10/602,947 CHOI ET AL. Notice of References Cited Art Unit Examiner Page 1 of 1 (Nancy) Thanh-Nhan P Nguyen 2871

Application/Control No.

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2002/0159012	10-2002	Yamada, Tsutomu	349/122
	В	US-2002/0089630	07-2002	Liu et al.	349/129
	С	US-			
	D	US-			
	Е	US-			
	F	US-			
	Ġ	US-			
	Н	US-			
	ı	US-			
	J	US-			
	к	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2002090531 A	03-2002	Japan	YANO et al.	G02B 05/30
	0					
	Р					
	Q					
	R					
	s					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	٧	
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.